

<b>Notice of References Cited</b>	Application/Control No. 10/738,459		Applicant(s)/Patent Under Reexamination TOUR ET AL.	
	Examiner Edna Wong		Art Unit 1753	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0180244	09-2004	Tour et al.	429/013
*	B	US-2004/0222080	11-2004	Tour et al.	204/157.15
*	C	US-7,014,737	03-2006	Harutyunyan et al.	204/158.2
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 200175903 A1	10-2001	World Intellect	HJORTSTAM et al.	H01B 1/04
	O	KO 20020046342	06-2002	Korea	YEE et al.	A61N 5/02
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Holtzinger et al., "Sidewall Functionalization of Carbon Nanotubes", Angew. Chem. Int. Ed. (no month, 2001), Vol. 40, No. 21, pp. 4002-4005.
	V	Fliflet et al., "Application of Microwave Heating to Ceramic Processing: Design and Initial Operation of a 2.45-GHz Single-Mode Furnace", IEEE Transactions on Plasma Science, Vol. 24, No. 3, June 1996, pp. 1041-1049.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.